



PATENT
3430-0131P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): HWANG, Kwang-Jo CONF.: 5562
SERIAL NO.: 09/648,111 GROUP: 2815
FILED: August 25, 2000 EXAMINER: BROCK II, P.
FOR: METHOD OF PATTERNING A METAL LAYER IN A
 SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 5, 2005
(Tuesday after Holiday)

Dear Sir:

In response to the non-final Office Action dated February 3, 2005, the period for response having been extended two (2) months to July 3, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes Amendments to the Claims and Remarks.